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| APPLICATION NUMBER | FILING OR 371(c) DATE | FIRST NAMED APPLICANT | ATTY. DOCKET NO./TITLE |
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| 10/587,194         | 07/24/2006            | Jean-Louis Stehle     | 58059/N75              |

**CONFIRMATION NO. 8444** 

23363 CHRISTIE, PARKER & HALE, LLP PO BOX 7068 PASADENA, CA91109-7068

Title: Protected pattern mask for reflection lithography in the extreme uv or soft x-ray range

Publication No. US-2007-0160913-A1

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